MEMS inclinometer



Description

Model 5310 MEMS inclinometer has MEMS, it supply very excellent resolution and accuracy in real-time.

Model 5310 that was added the amplification circuit to the MEMS sensor can measure dynamically, semi-permanently, and in real-time.

We provide 2 types of MEMS inclinometer as 1axis (0 $^{\circ}$, and 180 $^{\circ}$) and 2axis(0 $^{\sim}$ 180 $^{\circ}$, 90 $^{\sim}$ 270 $^{\circ}$)

MEMS inclinometer of our company has much confidence because it adjusts with high precision of angle division device. You can use MEMS inclinometer by establishing the sensor bracket in the zone or building where inclination is expected and then attaching MEMS inclinometer and confirm initial measurement. The difference between initial value and current value is angle variation. You can measure precisely by provided conversion factor.

MEMS inclinometer is designed for waterproof, rustproof and shock absorption by precise process of stainless steel.

Features

- Stability and confidence with which it can operated in severe environment
- Selection of anticorrosive and rustproof material
- 105m H₂O waterproof
- Selected materials to minimize thermal zero shift
- Dynamic measurement is possible
- Easy installation by circular level

Ancillary equipments

- Power supply (±12 VDC)
 Protective cover
- Universal terminal box (model 7012/7024)



[5420M beam sensor]

Ordering information ,

- Cable length
 Application field
- Application of uniaxial and biaxial type
- Limits degree of measured data for structure
- Keeping readout unit

The readout |

It is connected to the system such as the voltage readout units, or data logger as it is the electrical sensor that output \mbox{mV}

- · ACE-1500 (MEMS readout)
- · ACE-900 series (MEMS mini logger)
- ADL-200A (Smart logger)

Applications

Dynamic measurement is possible MEMS inclinometer that it suits for study object or spot where needs real time measurement.

- Measurement of inclination followed by the effect of open cut or excavation
- Measurement of inclination of beam and abutment
- Measurement of deformation or inclination of retaining wall
- Measurement of movement or convergent of tunnel
- Measurement of inclination of a vessel

Specification ,

Model	5310	5310B	5310A	5310AB
Sensor element	MEMS sensor			
	(Micro electro mechanical system)			
Range	±5°~±10°			
Measure direction	1 axis	2 axis	1 axis	2 axis
Rating output	-5~5 VDC		4~20mA	
Accuracy	±0.1% FSR			
Non-linearity	±0.5% FSR			
Input voltage	+12V, -12V		18 ~ 24VDC	
Operating temperature	-30~80℃			
Waterproof	105m H ₂ O			
Materials	Stainless steel, O-ring			
Weight	① Inclinometer 0.3kg/1axis,0.5kg/2axis			
	② Mounting bracket 0.2kg			
Signal cable	Ø4.5mm, 0.24mm ² ×4C			
	shielded PVC sheath cable			
	① Mounting bracket			
Accessories	② 3/8" Anchor bolt			
	③ Anchor plate			



[Installation of MEMS inclinometer]